

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1762**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI et al.

Application No.: 09/701,534

Filed: November 30, 2000

For: METHOD FOR FORMING SILICON FILM AND INK COMPOSITION FOR INK JET

Group Art Unit: 1762

Examiner: M. Cleveland

Docket No.: 107291

#10/c
Hyda
7/8/03
(NE)

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 9, 2003 Final Office Action, please consider the following:

Amendments to the Claims are reflected in the listing of claims; and

Remarks.

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